



Docket No. 740756-2183

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI

Serial No. 09/620,968

Filed: July 20, 2000

For: METHOD OF FORMING INSULATING FILMS,  
CAPACITANCES, AND SEMICONDUCTOR  
DEVICE

)

) Group Art Unit: 2814

) Examiner: Nathan W. Ha

) Confirmation No. 4214

) Date: January 30, 2006

CERTIFICATE OF MAILING OR TRANSMISSION  
[37 CFR 1.8(a)]

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Signature: \_\_\_\_\_

Name: \_\_\_\_\_

REQUEST FOR RECONSIDERATION

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the final Office Action mailed October 28, 2005, please consider Applicant's remarks in connection with the above identified application as follows.